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<tr>
<th>Information</th>
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<tr>
<td>Keywords</td>
<td>power MOSFET, single-shot, avalanche, ruggedness, safe operating condition</td>
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<tr>
<td>Abstract</td>
<td>Power MOSFETs are normally measured based on single-shot Unclamped Inductive Switching (UIS) avalanche energy. This application note describes in detail, the avalanche ruggedness performance, fundamentals of UIS operation and appropriate quantification method for the safe operating condition.</td>
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</tbody>
</table>
1. Introduction

Electronic applications have progressed significantly in recent years and have inevitably increased the demand for an intrinsically rugged power MOSFET. Device ruggedness defines the capacity of a device to sustain an avalanche current during an unclamped inductive load switching event. The avalanche ruggedness performance of a power MOSFET is normally measured as a single-shot Unclamped Inductive Switching (UIS) avalanche energy or $E_{DS(ALS)}$. It provides an easy and quick method of quantifying the robustness of a MOSFET in avalanche mode. However, it does not necessarily reflect the true device avalanche capability (see Ref. 1, Ref. 2 and Ref. 3) in an application.

This application note explains the fundamentals of UIS operation. It reviews the appropriate method of quantifying the safe operating condition for a power MOSFET, subjected to UIS operating condition. The application note also covers the discussions on repetitive avalanche ruggedness capability and how this operation can be quantified to operate safely.

2. Single-shot and repetitive avalanche definitions

Single-shot avalanche events are avalanche events that occur due to a fault condition in the application such as electrical overstress. The application does not have an avalanche designed into its operation.

However, repetitive avalanche refers to the applications where avalanche is an intended operation mode of the MOSFET. Here, avalanche is a designed function and has a limited number of operations to ensure reliability of the MOSFET over its life. The number of allowed events is a function of the avalanche energy and can be determined from the data sheet charts found on repetitive avalanche specific parts – ending in suffix R e.g. BUK9K51-60R.

Any customer wishing to operate outside the current avalanche ratings may be considered on an application basis. Contact your local sales team for more information.

3. Understanding power MOSFET single-shot avalanche events

The researchers and the industry have established single-shot avalanche capability of a device (see Ref. 1, Ref. 2 and Ref. 3). The test is carried out on a simple unclamped inductive load switching circuit, as shown in Fig. 1.

![Fig. 1. Unclamped inductive load test circuit for MOSFET ruggedness evaluation](image)
3.1. Single-shot UIS operation

A voltage pulse is applied to the gate to turn on the MOSFET, as shown in Fig. 2. It allows the load current to ramp up according to the inductor value (L) and the drain supply voltage (V_{DD}). The phenomenon is shown in Fig. 3 and Fig. 4. At the end of the gate pulse, the MOSFET is turned off. The current in the inductor continues to flow, causing the voltage across the MOSFET to rise sharply. This overvoltage is clamped at breakdown voltage (V_{BR}) until the load current reaches zero, as illustrated in Fig. 3. Typically, V_{BR} is:

\[
V_{BR} \approx 1.3 \times V_{(BR)DSS}
\] (1)

The peak load current passing through the MOSFET before turn off is the non-repetitive drain-source avalanche current (I_{DS(AL)S}) of the UIS event. I_{DS(AL)S} is illustrated in Fig. 4. The following expression is used to determine the rate at which the avalanche current decays, which is dependent on the inductor value:

\[
\frac{dI_{DS(AL)S}}{dt_{AL}} = -\frac{V_{BR} - V_{DD}}{L}
\] (2)

The peak drain-source avalanche power (P_{DS(AL)M}) dissipated in the MOSFET is shown in Fig. 5. It is a product of the breakdown voltage (V_{BR}) and the non-repetitive drain-source avalanche current (I_{DS(AL)S}); see Fig. 3 and Fig. 4. The avalanche energy dissipated is the area under the P_{AV} waveform and is estimated from the following expression:

\[
E_{DS(AL)S} = \frac{P_{DS(AL)M}}{2} \times t_{AL}
\] (3)

or:

\[
E_{DS(AL)S} = \frac{1}{2} \cdot \frac{V_{BR}}{V_{BR} - V_{DD}} \cdot L I_{DS(AL)S}^2
\] (4)

Another crucial parameter involved in a MOSFET avalanche event is the junction temperature. After the avalanche event (t) has begun, the following expression is used to determine the transient junction temperature variation during device avalanche at a given time:

\[
\Delta T_j(t) = \int_0^t P_{AV}(t) \frac{dZ_{th}(t-t)}{dt} dt
\] (5)

where Z_{th} is the power MOSFET transient thermal impedance. Alternatively, the following expression approximates the maximum \(\Delta T_j\):

\[
\Delta T_{j(max)} \approx \frac{2}{3} P_{DS(AL)M} Z_{th}(t_{AL}/2)
\] (6)

Assuming that \(T_{j(max)}\) occurs at \(t_{AL}/2\), \(Z_{th}(t_{AL}/2)\) is the transient thermal impedance measured at half the avalanche period \(t_{AL}\). Note, the \(Z_{th}\) value used for the avalanche calculation is more conservative than the one published in data sheets due to the nature of avalanche.

Therefore, the maximum junction temperature resulting from the avalanche event is:
\[ T_{j(\text{max})} \approx \Delta T_{j(\text{max})} + T_j \] (7)

where \( T_j \) refers to the junction temperature prior to turn off.

3.1.1. Single-shot UIS waveforms

![Gate-source voltage, \( V_{GS} \)](image)

![Drain-source voltage, \( V_{DS} \)](image)

![Drain current, \( I_D \)](image)

![Peak drain-source avalanche power, \( P_{DS(AL)M} \)](image)

![Transient junction temperature profile of MOSFET during an avalanche event](image)

3.2. Single-shot avalanche ruggedness rating

The failure mechanism for a single-shot avalanche event in a power MOSFET is due to the junction temperature exceeding the maximum temperature rating. In such a case, catastrophic damage occurs to the MOSFET. If the transient temperature resulting from an avalanche event, as shown in Fig. 6, rises beyond a recommended rated value, the device risks being degraded. The recommended rated value is de-rated from the maximum temperature for optimum reliability.

Blackburn (see Ref. 2) has discussed a general guideline in detail, on the appropriate method of quantifying the single-shot avalanche capability of a device. It takes the avalanche current and initial junction temperature into consideration. The maximum allowed avalanche current as a function of avalanche time defines the safe operation for a device single-shot UIS event. The maximum allowed avalanche current is set so that a safe maximum junction temperature, \( T_{j(\text{max})} \) of 175 °C, is never exceeded. Using Equation 7, Fig. 7 is plotted.
4. Understanding power MOSFET repetitive avalanche events

Repetitive avalanche refers to an operation involving repeated single-shot avalanche events, as discussed earlier. Until recently, most manufacturers have avoided the issues pertaining to the power MOSFET repetitive avalanche capability. It is primarily due to the complexity in such operations and the difficulties in identifying the underlying physical degradation process in the device.

Due to the traumatic nature of the avalanche event, a repetitive avalanche operation can be hazardous for a MOSFET. It is hazardous even when the individual avalanche events are below the single-shot UIS rating. This type of operation involves additional parameters such as frequency, duty cycle, and thermal resistances ($R_{th(j-a)}$ and $R_{th(j-mb)}$) of the system during the avalanche event. However, it is possible to de-rate the single-shot rating to define a repetitive avalanche SOAR.

4.1. Repetitive UIS operation

The repetitive UIS test circuit is shown in Fig. 1. The gate is fed with a train of voltage pulses at a frequency ($f$) and for a duty cycle as shown in Fig. 8. The resulting breakdown voltage ($V_{BR}$) and drain current ($I_D$) passing through the load are the same as for a single-shot UIS. However, the peak $I_D$ is now denoted as repetitive drain-source avalanche current ($I_{DS(AL)R}$), as shown in Fig. 9.

The repetitive drain-source avalanche power ($P_{DS(AL)R}$) resulting from the repetitive UIS operation is shown in Fig. 10. For finding the value of $P_{DS(AL)R}$, it is necessary to first calculate $E_{DS(AL)S}$ for a single avalanche event using Equation 3. This resultant value of $E_{DS(AL)S}$ is substituted in the following expression, to calculate the value of $P_{DS(AL)R}$:

$$ P_{DS(AL)R} = E_{DS(AL)S} \times f $$

(8)
4.1.1. Repetitive UIS waveforms

![Waveform Diagrams]

4.2. Temperature components

The temperature rise from the repetitive avalanche mode in the power MOSFET is shown in Fig. 11.

The temperature \( T_{j(init)} \) comprises the mounting base temperature \( T_{mb} \) and the temperature rise resulting from any on-state temperature difference \( \Delta T_{on} \).

\[
T_{j(init)} = T_{mb} + \Delta T_{on} \tag{9}
\]

In addition, there is a steady-state average junction temperature variation \( \Delta T_{j} \) resulting from the average repetitive avalanche power loss.

\[
\Delta T_{j} = P_{DS(AL)R} \times R_{th(j-a)} \tag{10}
\]

where \( R_{th(j-a)} \) is the thermal resistance from junction to ambient of the device in the application. The summation of Equation 9 and Equation 10 gives the average junction temperature, \( T_{j(AV)} \) of a power MOSFET in repetitive UIS operation.

\[
T_{j(AV)} = T_{j(init)} + \Delta T_{j} \tag{11}
\]
5. Repetitive avalanche ruggedness rating

Our investigations show that there is more than one failure or wear-out mechanism involved in repetitive avalanche. Temperature is not the only limiting factor to a repetitive avalanche operation. However, by limiting temperature and the repetitive drain-source avalanche current ($I_{DS(ALR)}$), an operating environment is defined such that the avalanche conditions do not activate device degradation. It allows the power MOSFET to operate under repetitive UIS conditions safely.

Fig. 12 shows the repetitive avalanche SOAR curve of BUK9K51-60R, where for each avalanche event the $T_j$ rise is limited to 30 K.

![Fig. 12. Repetitive avalanche rating; avalanche current](image)

The three conditions which must be satisfied for safe operation of a power MOSFET under repetitive avalanche mode are:

1. $I_{(AL)}$ should not exceed the repetitive avalanche SOAR curve
2. $T_j$ should not exceed 175 °C
3. The number of cycles should not exceed the avalanche cycle limit chart

The number of allowable cycles can be determined through a second chart in the avalanche MOSFET’s data sheet, (see Fig. 13).

![Fig. 13. Repetitive avalanche rating; maximum number of avalanche events as a function of avalanche energy](image)
6. Conclusion

Power MOSFETs can sustain single-shot and repetitive avalanche events. Simple design rules and SOAR regions are provided.

7. Examples

The following examples examine cases of avalanche operation acceptance:

7.1. Single-shot avalanche case

- Device: BUK9K51-60R; see Fig. 7
- \( L = 30 \, \mu H \)
- \( I_{(AL)} = 18 \, A \)
- \( R_{(th(j-a))} = 5 \, K/W \)
- \( V_{(BR)DSS} = 60 \, V \)
- \( V_{DD} = 0 \, V \)

7.1.1. Calculation steps

1. Using the above information, \( t_{AL} \) can be determined using Equation 2, which in this case is 7 μs. Transferring the \( I_{AL} \) and \( t_{AL} \) conditions onto Fig. 12, the operating point is under the SOAR curve. It suggests that the operating condition may be feasible.

7.2. Repetitive avalanche case

- Device: BUK9K51-60R; see Fig. 12 and Fig. 13
- \( L = 30 \, \mu H \)
- \( I_{(AL)} = 10 \, A \)
- \( f = 3 \, kHz \)
- \( R_{(th(j-a))} = 5 \, K/W \)
- \( T_{0} = 100 \, ^{\circ}C \)
- \( V_{(BR)DSS} = 60 \, V \)
- \( V_{DD} = 0 \, V \)

7.2.1. Calculation steps

1. From the above information, \( t_{AL} \) can be determined using Equation 2, which in this case is approximately 4 μs. Transferring the \( I_{AL} \) and \( t_{AL} \) conditions onto Fig. 12, the operating point is under the boundary of the ‘Rep. Ava’ SOAR curve. It suggests that the operating condition is acceptable. Therefore, condition 1 is satisfied.

2. Calculate the non-repetitive drain-source avalanche energy \( E_{DS(AL)S} \) using Equation 3 \( (E_{DS(AL)S} = 1.56 \, mJ) \).

3. Calculate the repetitive drain-source avalanche power \( P_{DS(AL)R} \) using Equation 8 \( (P_{DS(AL)R} = 4.68 \, W) \).

4. Calculate the average \( \Delta T_{j} \) rise from repetitive avalanche \( (\Delta T_{j}) \) using Equation 10 \( (\Delta T_{j} = 123.4 \, ^{\circ}C) \).

5. Determine the average junction maximum temperature in repetitive avalanche operation \( (T_{j(AV)}) \) using Equation 11 \( (T_{j(AV)} = 153 \, ^{\circ}C) \). Therefore, condition 2 is satisfied.

6. Finally based on the energy we can determine the limit number of operations at these conditions from Fig. 13, \( (No. \, events = 8e^{9}) \).

Based on the above calculations, the operating conditions meet the repetitive avalanche requirements with a limited number of repetitive events of \( 8e^{9} \).
8. Appendix A

The following table describes the symbols used throughout this application note.

### Table 1. Description of symbols

<table>
<thead>
<tr>
<th>Symbol</th>
<th>Description</th>
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</thead>
<tbody>
<tr>
<td>$V_{(BR)DSS}$</td>
<td>drain-source breakdown voltage</td>
</tr>
<tr>
<td>$E_{DS(Al)S}$</td>
<td>non-repetitive drain-source avalanche energy</td>
</tr>
<tr>
<td>$I_D$</td>
<td>drain current</td>
</tr>
<tr>
<td>$I_{DS(Al)S}$</td>
<td>non-repetitive drain-source avalanche current</td>
</tr>
<tr>
<td>$I_{DS(Al)R}$</td>
<td>repetitive drain-source avalanche current</td>
</tr>
<tr>
<td>$I_{AL}$</td>
<td>avalanche current</td>
</tr>
<tr>
<td>$L$</td>
<td>inductance</td>
</tr>
<tr>
<td>$P_{DS(Al)M}$</td>
<td>peak drain-source avalanche power</td>
</tr>
<tr>
<td>$P_{DS(Al)R}$</td>
<td>repetitive drain-source avalanche power</td>
</tr>
<tr>
<td>$R_{th(j-a)}$</td>
<td>thermal resistance from junction to ambient</td>
</tr>
<tr>
<td>$R_{th(j-mb)}$</td>
<td>thermal resistance from junction to mounting base</td>
</tr>
<tr>
<td>$T_{j(init)}$</td>
<td>initial junction temperature [1]</td>
</tr>
<tr>
<td>$\Delta T_{on}$</td>
<td>on-state temperature difference</td>
</tr>
<tr>
<td>$T_{j}$</td>
<td>junction temperature</td>
</tr>
<tr>
<td>$\Delta T_{j}$</td>
<td>junction temperature variation</td>
</tr>
<tr>
<td>$T_{j(max)}$</td>
<td>maximum junction temperature</td>
</tr>
<tr>
<td>$T_{j(AV)}$</td>
<td>average junction temperature [2]</td>
</tr>
<tr>
<td>$T_{mb}$</td>
<td>mounting base temperature</td>
</tr>
<tr>
<td>$t_{AL}$</td>
<td>avalanche time</td>
</tr>
<tr>
<td>$V_{BR}$</td>
<td>breakdown voltage</td>
</tr>
<tr>
<td>$V_{DS}$</td>
<td>drain-source voltage</td>
</tr>
<tr>
<td>$V_{GS}$</td>
<td>gate-source voltage</td>
</tr>
<tr>
<td>$Z_{th}$</td>
<td>transient thermal impedance</td>
</tr>
<tr>
<td>$Z_{th(jA/2)}$</td>
<td>transient thermal impedance [3]</td>
</tr>
<tr>
<td>$V_{DD}$</td>
<td>supply voltage</td>
</tr>
</tbody>
</table>

[1] Summation of $T_{mb}$ and $\Delta T_{on}$.


9. Abbreviations

### Table 2. Abbreviations

<table>
<thead>
<tr>
<th>Acronym</th>
<th>Description</th>
</tr>
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<tbody>
<tr>
<td>MOSFET</td>
<td>Metal-Oxide Semiconductor Field-Effect Transistor</td>
</tr>
<tr>
<td>SOAR</td>
<td>Safe Operating ARea</td>
</tr>
<tr>
<td>UIS</td>
<td>Unclamped Inductive Switching</td>
</tr>
</tbody>
</table>
10. References


11. Revision history

<table>
<thead>
<tr>
<th>Revision number</th>
<th>Date</th>
<th>Description</th>
</tr>
</thead>
<tbody>
<tr>
<td>5.0</td>
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<td>Equation 6 corrected.</td>
</tr>
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<td>Document updated to latest Nexperia standards. Examples updated to use BUK9K51-60R.</td>
</tr>
<tr>
<td>3.0</td>
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<td>Section 2: added</td>
</tr>
</tbody>
</table>
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